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LADAS &amp; PARRY

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Application Serial No. 10/603,306  
Reply to Office Action of September 13, 2004

PATENT  
Docket: CU-3271

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

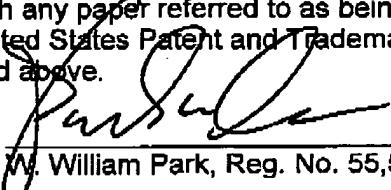
In re Application: Byung Kwon AHN et al. ] GRP ART UNIT: 2813  
Serial No: 10/603,306 ] Ex.: Pham, Thanhha S.  
Filed: June 25, 2003 ]  
For: METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

**Certification under 37 C.F.R. §1.8(a)**

The USPTO Central Fax No. (703) 872-9306

Date of Fax Transmittal: January 14, 2004.

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.



W. William Park, Reg. No. 55,523

The Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

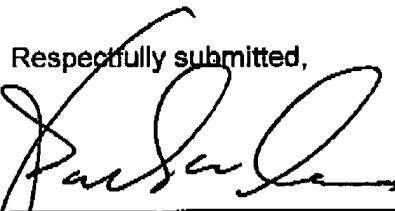
**REQUEST FOR TWO-MONTH EXTENSION OF TIME**

Dear Sir:

With reference to the Office Action dated September 13, 2004, Applicants hereby request an two-month extension of the term for response, which thereby extends the end date of the current term from December 13, 2004 to Monday, February 13, 2005.

Please charge \$450.00 to Deposit Account No. 12-0400 to cover the cost of the two-month extension. No other fee is believed to be required. However, if this is not the case, please charge any additional fee or credit any overpayment to the same Deposit Account No. 12-0400.

Respectfully submitted,



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Dated: January 14, 2005